



LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	ATTORNEY DOCKET NO.	SERIAL NO.
	SP03-099	10/632364
	APPLICANT: SCHROEDER J, et al.	
	FILING DATE 7/31/2003	GROUP: Unknown

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
<u>TM</u>	AA	5,374,921	12/20/94	Yabe et al			
<u>TM</u>	AB	5,824,127	10/20/98	Bange et al			
<u>TM</u>	AC	5,879,424	3/9/99	Nishii et al			
<u>TM</u>	AD	6,128,924	10/10/00	Bange et al			
	AE						
	AF						
	AG						
	AN						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AL						
	AM						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
<u>TM</u>	AN	Li et al.; "Three-dimensional Hole Drilling of Silica Glass from the Rear Surface with Femtosecond Laser Pulses"; Optics Letter/Vol. 26, No. 23; December 2001; pages 1912-1914					
<u>TM</u>	AO	Marcinkevicius et al.; "Femtosecond Laser-assisted Three-dimensional Microfabrication in Silica"; Optics Letter/Vol. 26, No. 5; March 2001; pages 277-279					
<u>TM</u>	AP	Streltsov et al.; "Fabrication and Analysis of a Directional Coupler Written in Glass by Nanojoule Femtosecond Laser Pulses"; Optics Letters/Vol. 26, No. 1; January 2001; pages 42-43.					
<u>TM</u>	AQ	Stoian et al.; Abstract of "The Dynamics of Ion Expulsion in Ultrashort Pulse Laser Sputtering of Al ₂ O ₃ "; Science Direct Web site; May 2000; 2 total pages.					

EXAMINER: Jineynt

DATE CONSIDERED:

04.2005

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 (REVISED)
JUN 26 2005

LIST OF PATENTS AND
PUBLICATIONS
FOR APPLICANTS INFORMATION
DISCLOSURE STATEMENT

ATTORNEY DOCKET NO.

SERIAL NO.

SP03-099

10/632,364

APPLICANT: Schroeder, Joseph F., et al.

FILING DATE 7/31/03

GROUP: 2874

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
TM	AA	US 6,362,453	3/26/02	Wang et al	219	121.69	3/15/99
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

AR	
AS	
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EXAMINER:

J. M. M.

DATE CONSIDERED:

04-2005

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

O I P E FEB 23 2005 PATENT & TRADEMARK OFFICE LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		ATTORNEY DOCKET NO. SP03-099	SERIAL NO. 10/632,364				
		APPLICANT: Alexander Streltsov, et al.					
		FILING DATE July 31, 2003	GROUP: 2874				
REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>TM</i>	AR	XP008035862: "Three-Dimensional Hole Drilling of Silica Glass From the Rear Surface with Femtosecond Laser Pulses"; Optics Letters, Optical Society of America; Volume 26, No. 23; December 1, 2001; Pages 1912-1914					
<i>TM</i>	AS	XP001019552: "Femtosecond Laser-Assisted Three-Dimensional Microfabrication in Silica"; Optical Letters, Optical Society of America; Volume 26, No. 5; March 1, 2001; Pages 277-279					
	AT						
	AU						
	AV						
	AW						
EXAMINER:	DATE CONSIDERED: <i>J. mg m</i> 04.2005						
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance <u>and</u> not considered. Include copy of this form with next communication to applicant.							